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PATENT
Atty. Dkt. No. AMAT/4969/CMP/ECP/RKK

1765

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Mok, et al.

Serial No.: 09/785,815

Confirmation No.: 4127

Filed: February 16, 2001

For: Integrated Semiconductor
Substrate Bevel Cleaning
Apparatus and Method

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

§§§§§ Group Art Unit: 1763

§§§§§ Examiner: Sylvia MacArthur

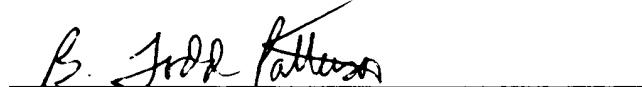
CERTIFICATE OF MAILING 37 CFR 1.8	
I hereby certify that this correspondence is being deposited on June 25, 2003 with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450	
6/25/03 Date	B. Todd Patterson Signature

PETITION FOR ONE-MONTH EXTENSION OF TIME

Applicant respectfully petitions the Commissioner under 37 CFR 1.136(a) to grant a one-month extension of time to and including June 26, 2003, in which to file the Response to Office Action Dated February 26, 2003.

This form is filed in duplicate. The Commissioner is authorized to charge the fee of \$110.00 and any additional fees which may be required for this submission to Deposit Account No. 20-0782/4969/CMP/ECP/NAN.

Respectfully submitted,


B. Todd Patterson
Registration No. 37,906
MOSER, PATTERSON & SHERIDAN, L.L.P.
3040 Post Oak Blvd., Suite 1500
Houston, Texas 77056
(713) 623-4844
ATTORNEY FOR APPLICANT

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OFFICE OF PETITIONS

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